

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hikaru Nishitani et al.

Serial No.: 10/530,500

Filed: 10/31/2005

For: PLASMA DISPLAY PANEL

Patent Examiner:

Group Art Unit: 2673

Confirmation No. 6681

January 31, 2007

Costa Mesa, California 92626

**SUPPLEMENTAL  
INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following references, which was found during the prosecution of a co-pending Chinese patent application:

Japanese Patent Application Publication No. 11-035372 w/English abstract  
Japanese Patent Application Publication No. 2001-110321 w/English abstract  
Japanese Patent Application Publication No. 11-339665 w/English abstract  
Japanese Patent Application Publication No. 2000-103614 w/English abstract

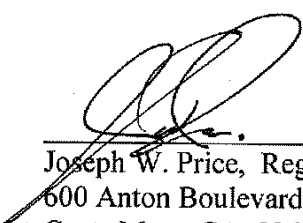
Copies of these foreign references and Form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing the information disclosure statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER LLP



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<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				<b>Docket Number (Optional)</b> 92478-1900		<b>Application Number</b> 10/530,500		
				<b>Applicant(s)</b> Hikaru Nishitani et al.				
				<b>Filing Date</b> 10/31/2005		<b>Group Art Unit</b> 2673		
<b>U. S. PATENT DOCUMENTS</b>								
<b>EXAMINER INITIAL</b>	<b>REF</b>	<b>DOCUMENT NUMBER</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE IF APPROPRIATE</b>	
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
<b>EXAMINER INITIAL</b>	<b>REF</b>	<b>DOCUMENT NUMBER</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE IF APPROPRIATE</b>	
<b>FOREIGN PATENT DOCUMENTS</b>								
	<b>REF</b>	<b>DOCUMENT NUMBER</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>Translation</b>	
							<b>YES</b>	<b>NO</b>
		11-035372	09.02.1999	Japan w/English abstract			X	
		2001-110321	20.04.2001	Japan w/English abstract			X	
		11-339665	10.12.1999	Japan w/English abstract			X	
		2000-103614	11.04.2000	Japan w/English abstract			X	
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
<b>EXAMINER</b>				<b>DATE CONSIDERED</b>				
<b>EXAMINER:</b> Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								